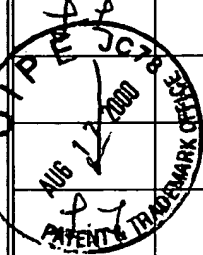


FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)  Submitted to the PTO: August 17, 2000		ATTY DOCKET NO. <b>862.C1883</b>		APPLICATION NO. <b>09/542,460</b>				
		APPLICANTS <b>TATSURO YAMAZAKI, ET AL.</b>						
		FILING DATE <b>April 4, 2000</b>		GROUP <b>Unassigned</b>				
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
		4,904,895	02/1990	Tsukamoto, et al.	313	336		
		5,066,883	11/1991	Yoshioka, et al.	313	309		
		5,569,974	10/1996	Morikawa, et al.	313	310		
		5,682,085	10/1997	Suzuki, et al.	315	169.1		
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	
f.i		4-28137	01/1992	Japan			Abstract	
↓		3-55738	03/1991	Japan			Abstract	
↓		64-31332	02/1989	Japan			Abstract	
f.i		2-257551	10/1990	Japan			Abstract	
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)								
f.i		M.I. Elinson, et al., "The Emission of Hot Electrons and the Field Emission of Electrons From Tin Oxide", Radio Engineering and Electronic Physics, pp. 1290-1296 (July 1965).						
↓		G. Dittmer, 'Electrical Conduction and Electron Emission of Discontinuous Thin Films', Thin Solid Films, 9, pp. 317-328 (1972).						
↓		H. Araki, et al., "Electroforming and Electron Emission of Carbon Thin Films", pp. 22-29 (January 26, 1983).						
f.i		M. Hartwell, et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", International Electron Devices Meeting, pp. 519-521 (1975).						
EXAMINER		LAO, LUN-YI			DATE CONSIDERED			8/7/04

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

